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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of : **Mail Stop: ISSUE FEE**
Eiichi ISHII et al. : **Confirmation No. 3781**
Serial No. 10/659,327 : [Group Art Unit 1753
Filed September 11, 2003 : Examiner Harry Wilkins, III]
METHOD OF SURFACE TREATMENT : Attorney Docket No. 2003_1290
OF TITANIUM METAL

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

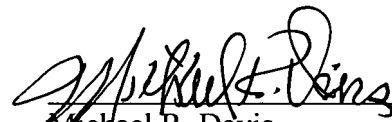
THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Sir:

Applicants are submitting herewith a copy of an Office Action issued October 19, 2004 in connection with the European application corresponding to the present U.S. application, and copies of the EP 0 305 241 reference (with English abstract) and the US 3,085,949 reference cited in the Office Action. [The GB 2 261 227 reference cited in the Office Action is already of record in the present U.S. application, having been cited in the IDS of September 11, 2003.] Under the provision of 37 CFR 1.97(i), it is requested that the instant IDS and attachments be placed in the file for the present application.

Respectfully submitted,

Eiichi ISHII et al.

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